



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 18, 2025

IGI Report Number **LG729570587**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.16 - 8.20 X 4.89 MM**

GRADING RESULTS

Carat Weight **2.01 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

Cut Grade **IDEAL**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG729570587**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila

LG729570587
Report verification at igi.org

LABORATORY GROWN DIAMOND REPORT



September 18, 2025

IGI Report Number

LG729570587

Description **LABORATORY GROWN DIAMOND**

ROUND BRILLIANT

Shape and Cutting Style **ROUND BRILLIANT**

8.16 - 8.20 X 4.89 MM

GRADING RESULTS

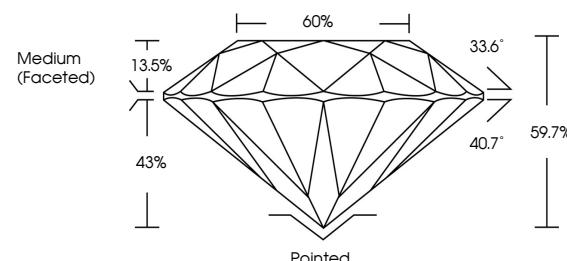
2.01 CARATS

E

VVS 2

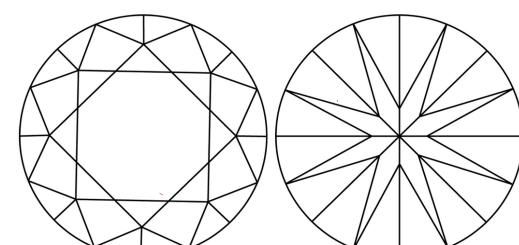
IDEAL

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
---	---	---	---	---	---	---	-------	------------	-------

CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
----	--------------------	-------------------	-------------------	------------------

Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
---------------------	-----------------------------	------------------------	-------------------	----------



ADDITIONAL GRADING INFORMATION

EXCELLENT

EXCELLENT

NONE

IGI LG729570587

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type Ila



FD - 10 20

September 18, 2025

IGI Report No LG729570587

ROUND BRILLIANT

Carat Weight

Color Grade

Clarity Grade

Cut Grade

Depth

Table

Girdle

Medium (Faceted)

Pointed

Excellent

Excellent

None

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type Ila